

Fabrication of Nanostructured Inconel 718 Alloys by Large Strain Extrusion Machining

Pin Yang*, Thomas E. Buchheit, and David D. Gill

Sandia National Laboratories

Albuquerque, NM 87185-1245

Christopher J. Saldana and Srinivasan Chandrasekar

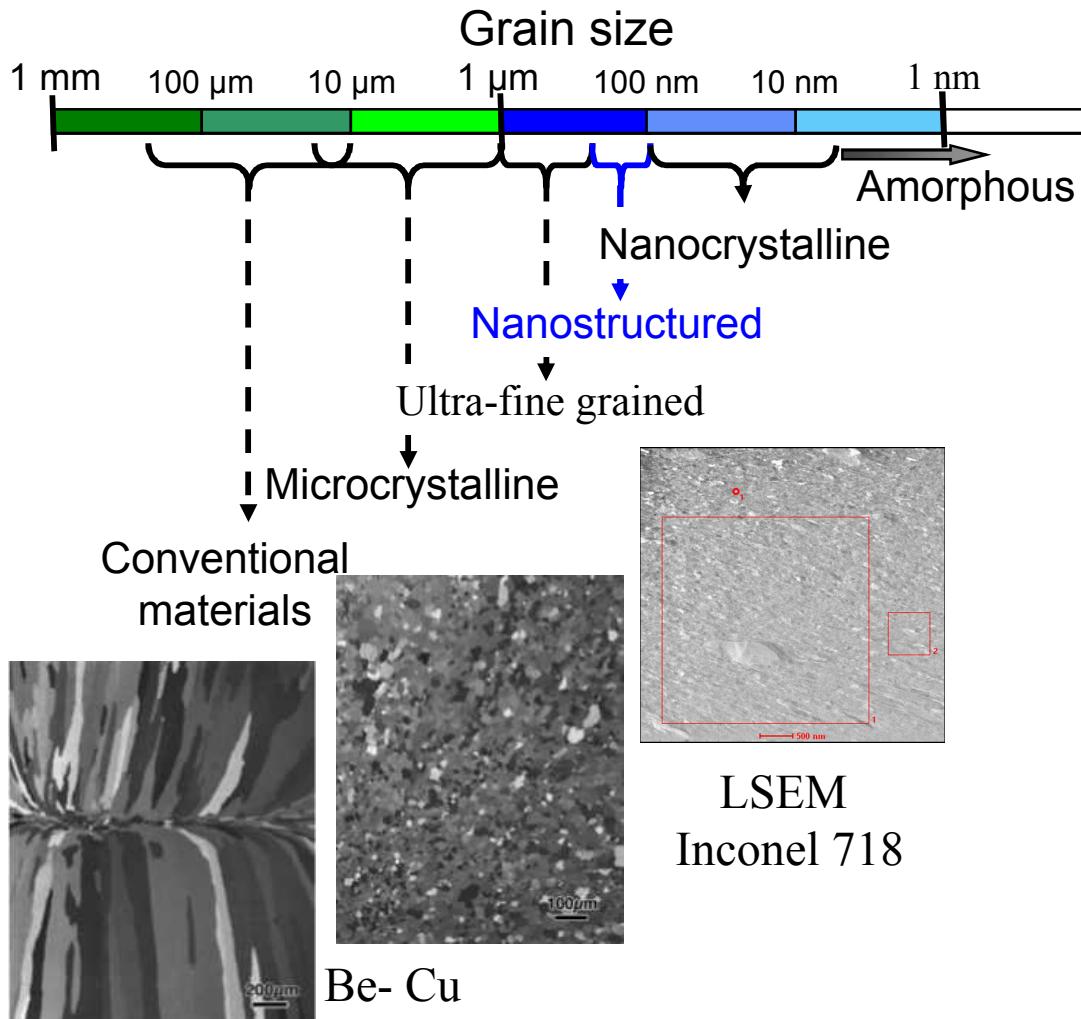
Center for Advanced Manufacturing

Purdue University

West Lafayette, IN 47907-2023

The 19th Annual Rio Grande Symposium on Advanced Materials
Albuquerque, New Mexico; October 9, 2007

Nanostructured metals have extraordinary properties and are comprised of nanometer-sized grains.

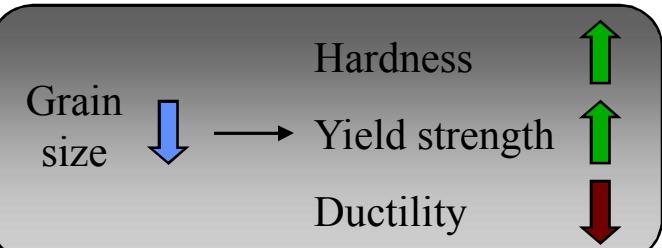


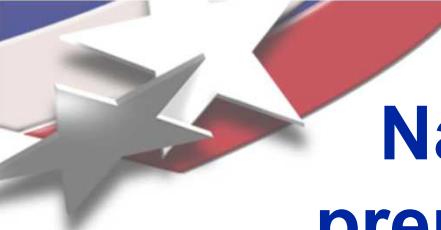
Microstructure ($< 1 \mu\text{m}$)

Nanocrystalline: $< 100 \text{ nm}$
Nanostructured: 100 nm - 300 nm
Ultra-fine grained: 300 nm – 1 μm

The grain size affects material properties...

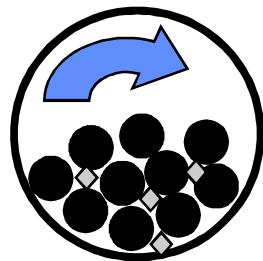
Increased strength $\longrightarrow \tau_y \sim \tau_0 + kd^{-1/2}$



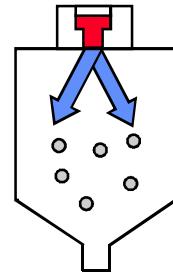


Nanostructured materials can be prepared through various processes.

Particulate

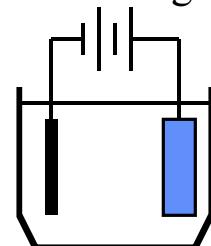


High-energy/cryogenic milling

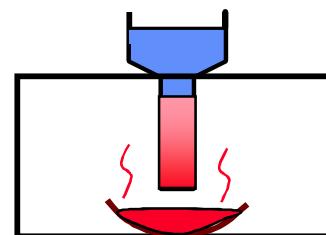


Gas atomization

Film

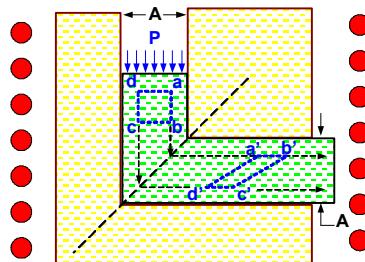


Electrodeposition

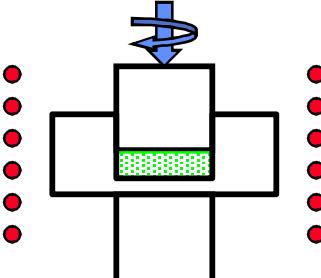


Gas condensation

Bulk



Equal channel angular extrusion



High pressure torsion

Long run time

High processing costs

Limited range of materials

Low output

Disadvantages

Multiple passes for high strains

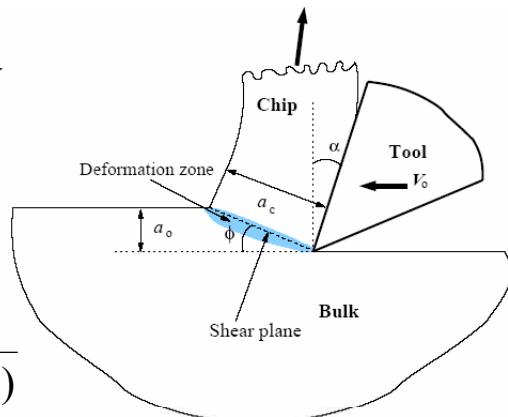
Limited for high-strength materials

Elevated temperatures necessary

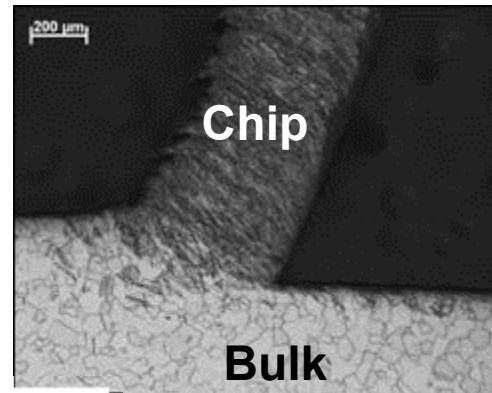
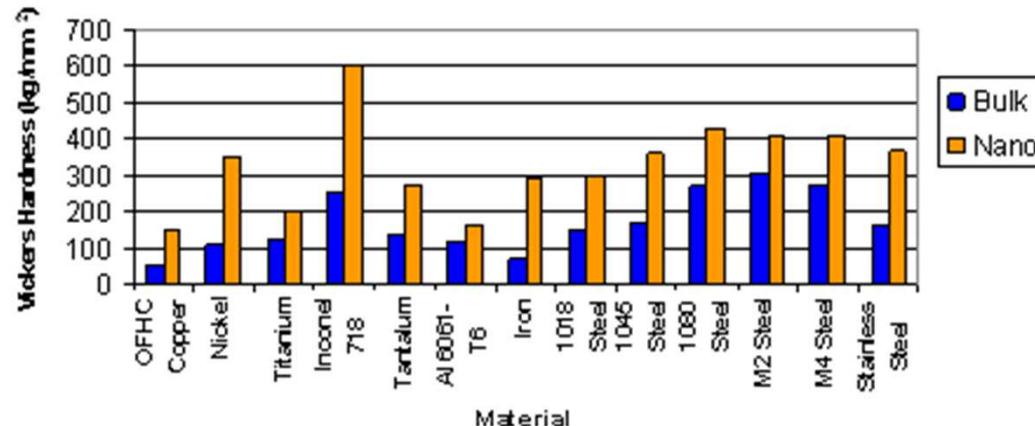
Machining is cost-effective production of nanostructured materials in any metal or alloy.

Severe plastic deformation by machining

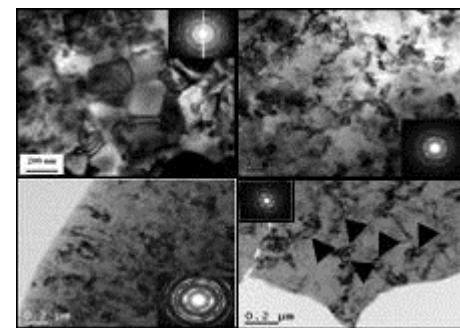
$$\gamma = \frac{\cos \alpha}{\sin \phi \cos(\phi - \alpha)}$$



Shear strains of 1-10 in a single pass



Purdue University (CMPT)

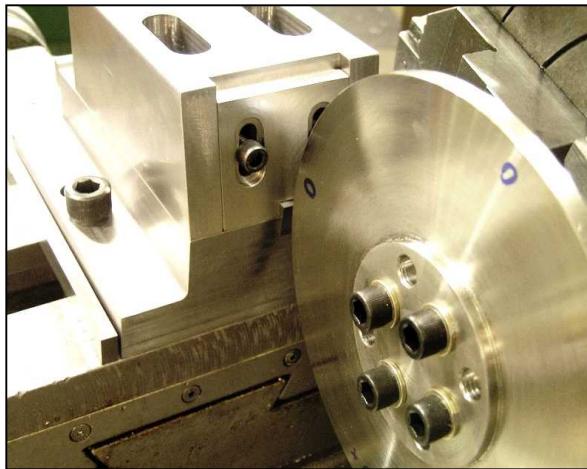


Purdue University (CMPT)

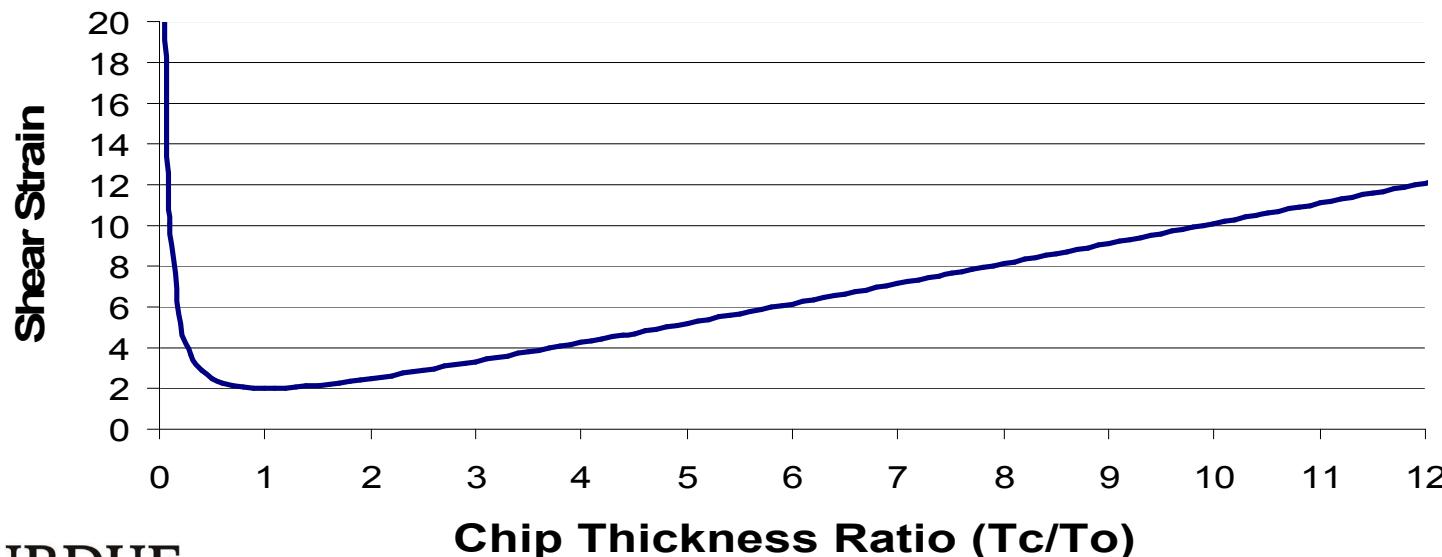
- Machining can result in increases in hardness and strength with nanostructured grain sizes.



LSEM is versatile to create bulk nanostructured metals for engineer applications.



Free machining vs. Extrusion machining

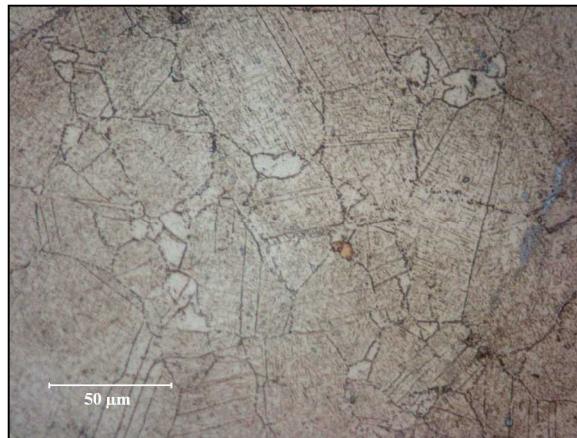


T_c : foil thickness
 T_o : depth of cut

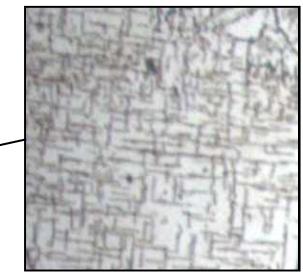
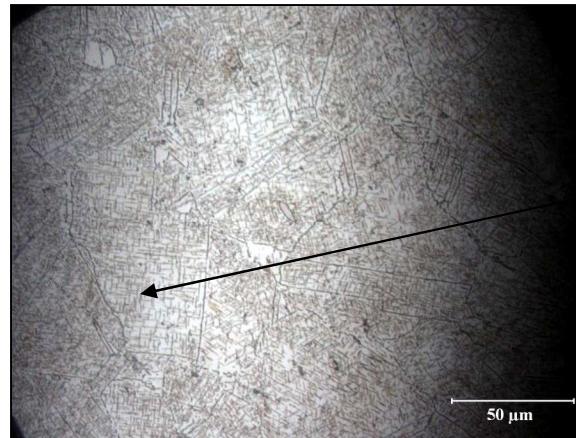


Optical Microscopy of Etched Bulk Inconel 718

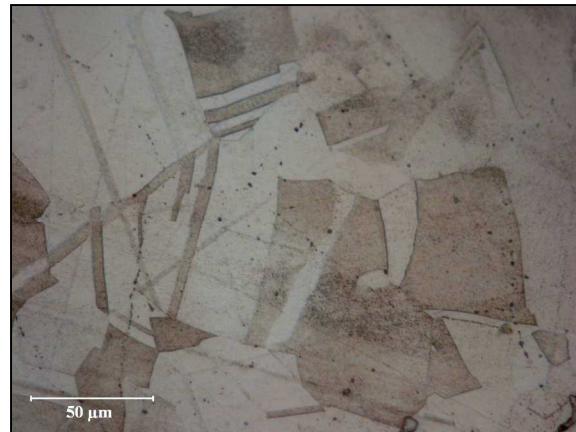
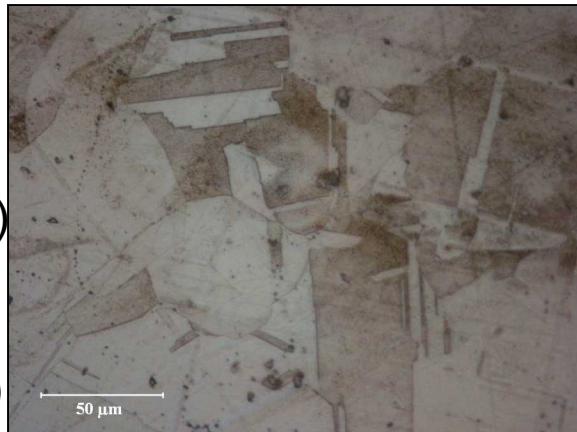
As received
bulk



15HRC
(ppt hardened)



Annealed bulk
(1037° C for 1hr)
1HRC
(solution treated)



Vickers Microhardness of Inconel 718

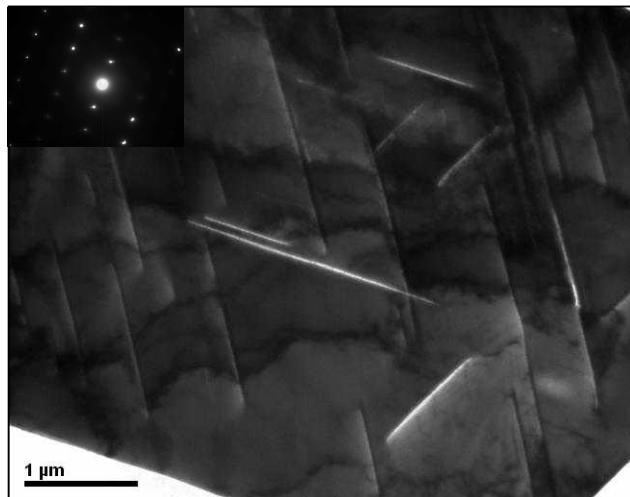
Incoming bulk material

Annealed bulk (1037° C for 1 hr)

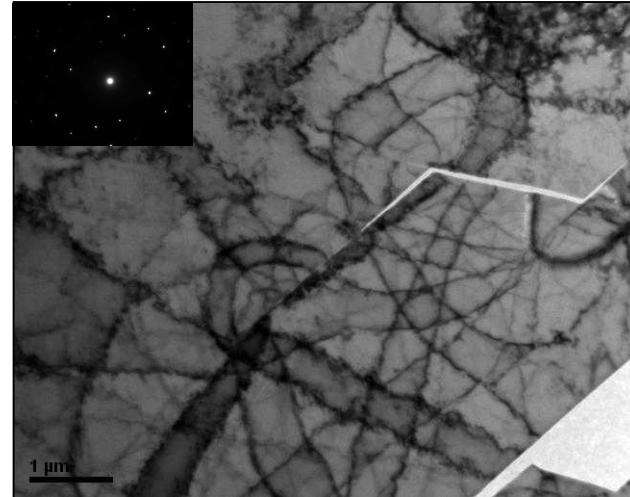
$221 \pm 7 \text{ kg/mm}^2$ (2.17 GPa)

As received bulk

$420 \pm 5 \text{ kg/mm}^2$ (4.12 GPa)



TEM - As received bulk Inconel 718



TEM - Annealed bulk (1037° C for 1hr)

Deformed material

Original Sandia Chip

$557 \pm 11 \text{ kg/mm}^2$ (33% increase)

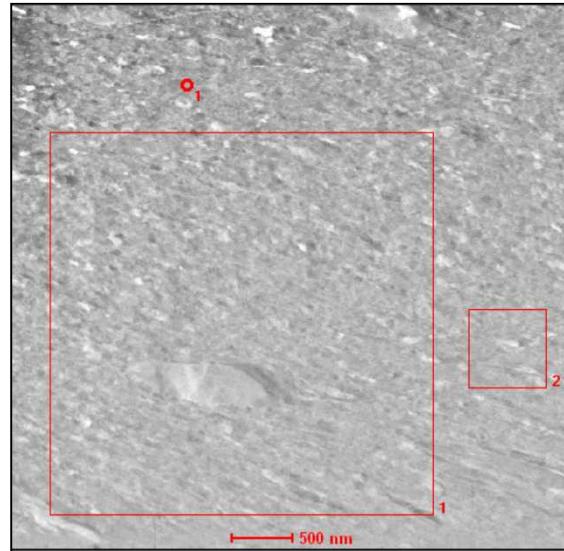
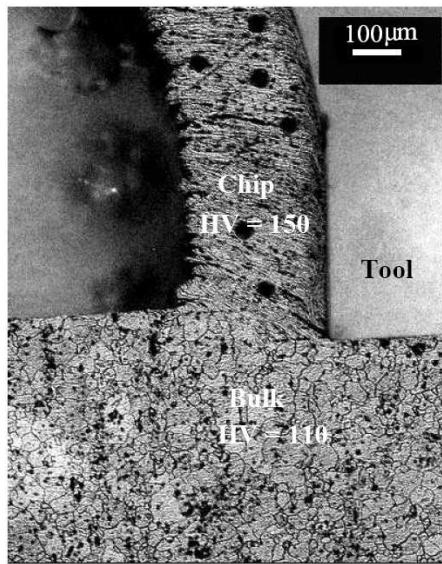
$\gamma \sim 2.1\text{-}2.5$

$494 \pm 22 \text{ kg/mm}^2$ (124% increase)

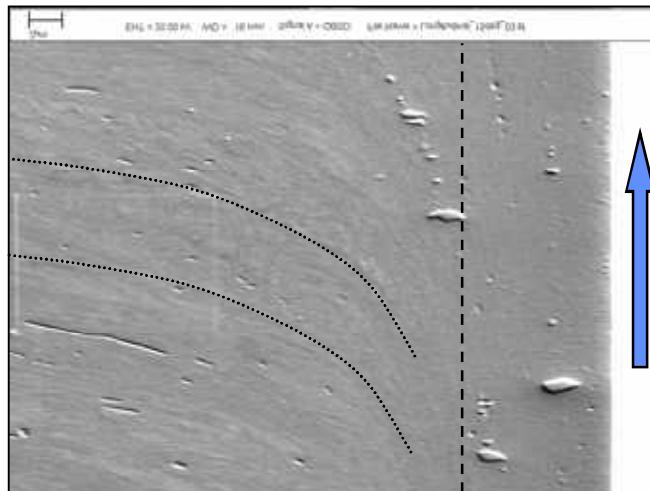
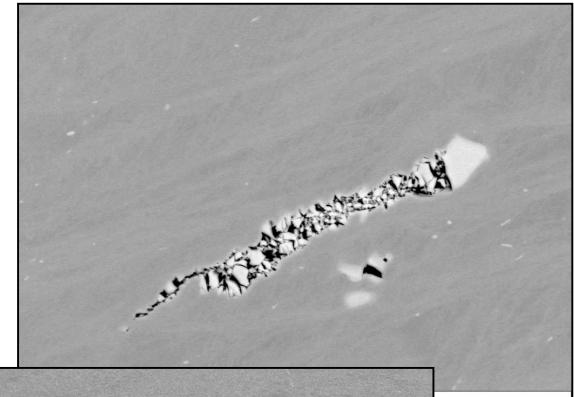
$\gamma \sim 3.3\text{-}3.5$

$562 \pm 11 \text{ kg/mm}^2$ (154% increase)

Microstructure of LSEM Inconel 718

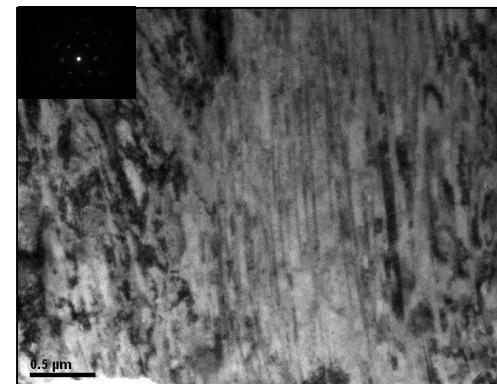


Nb rich carbide

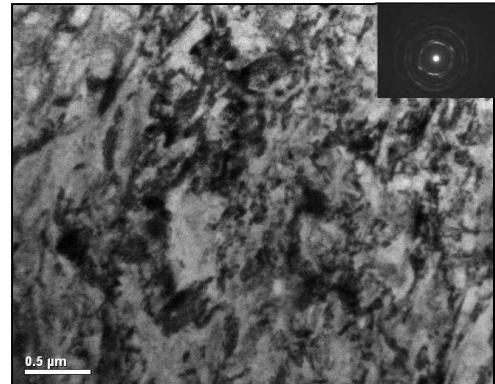


- Microscopic defects were created by LSEM process.

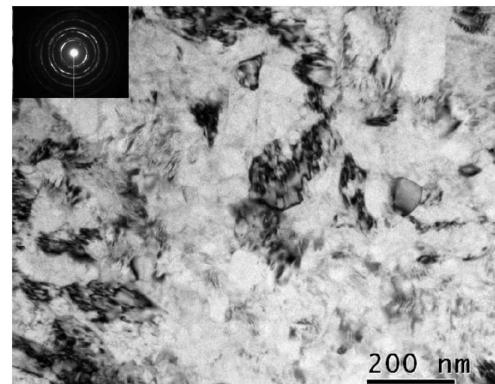
Different microstructures and properties can be created by Large Strain Extrusion Machining.



$\gamma = 2.1-2.5; 494 \pm 22 \text{ kg/mm}^2$

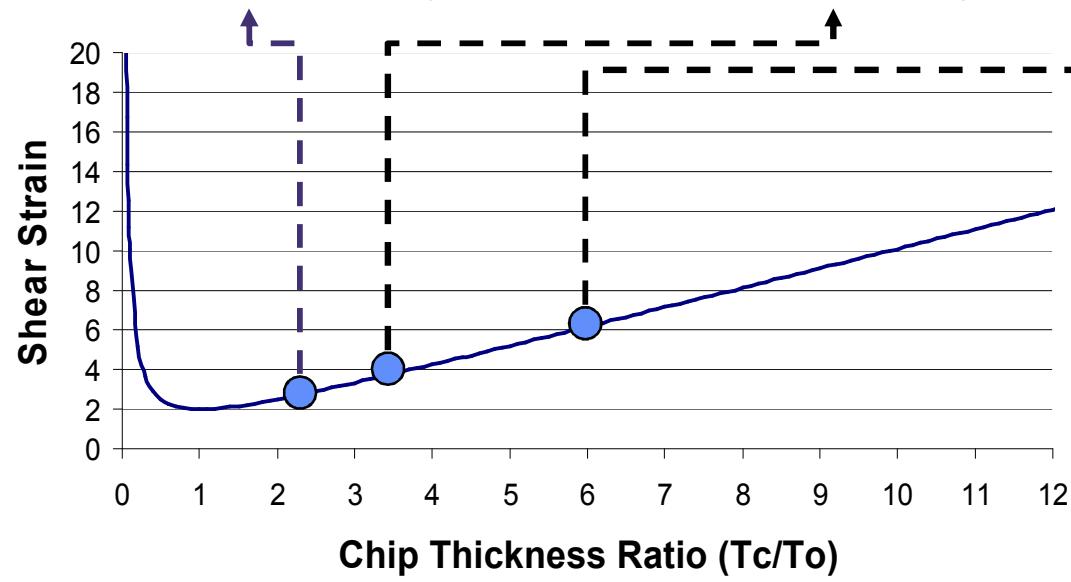


$\gamma = 3.3-3.5; 562 \pm 11 \text{ kg/mm}^2$

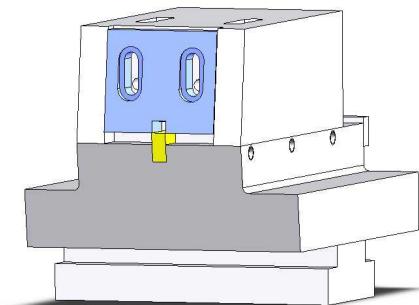


200 nm

$\gamma \sim 6$



Machining chips from annealed bulk material

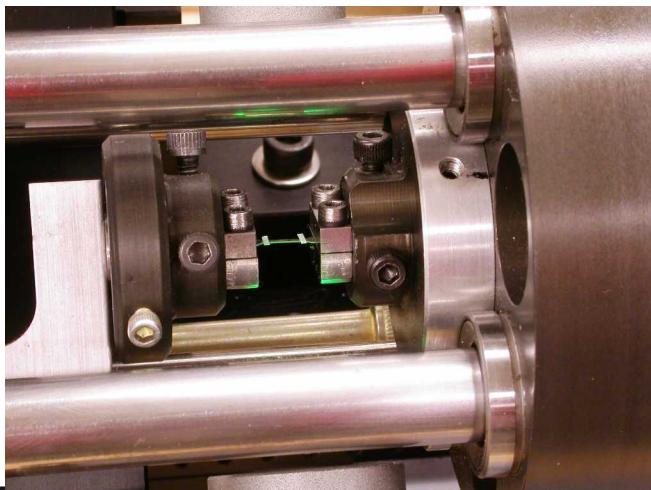
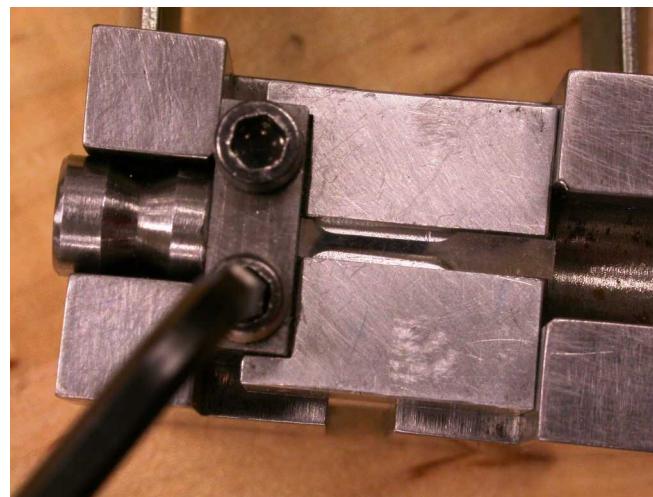
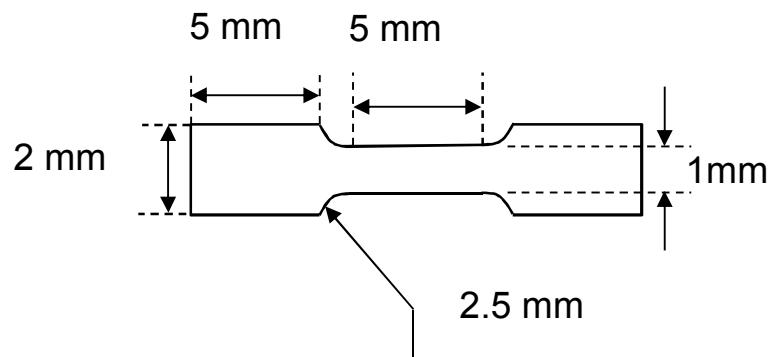


Variable foil thickness (T_c)

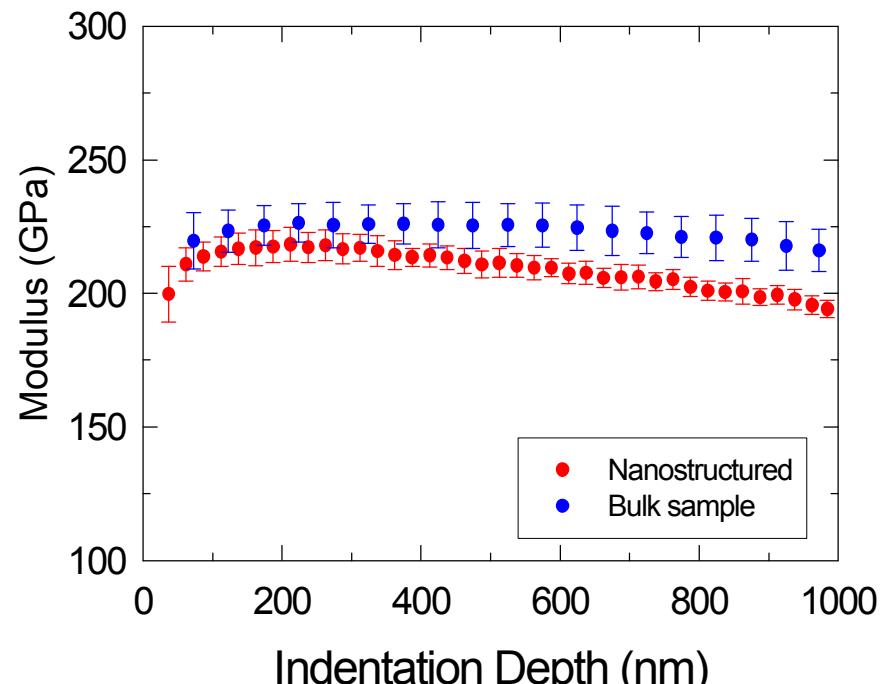
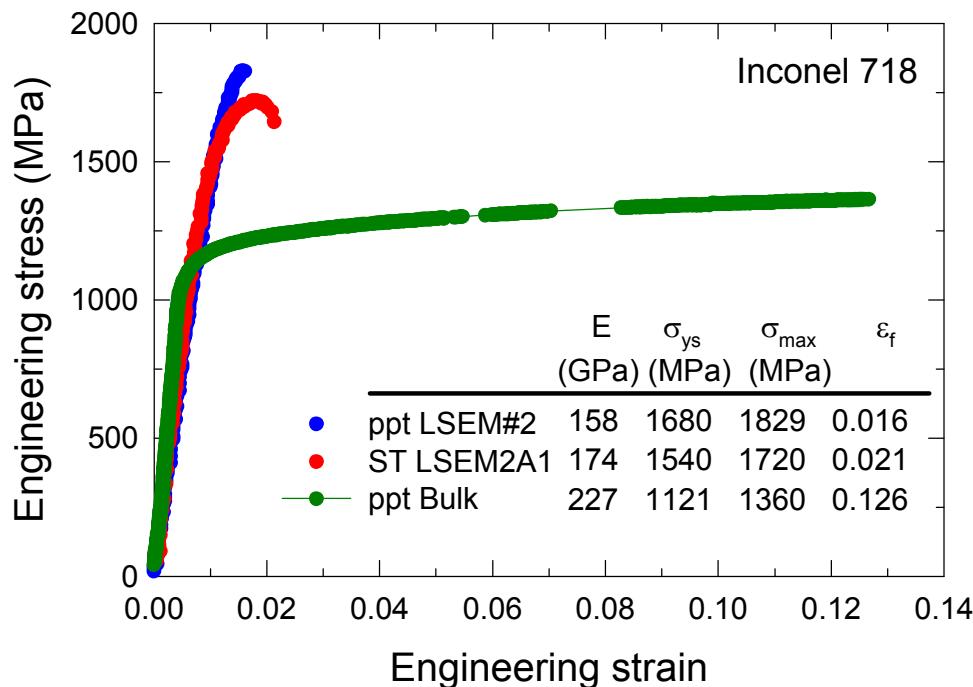
- Increasing strain results changes in the microstructure.



Micro-Tensile Tests



Extrusion machining greatly enhances material hardness and strength.



- Moderate tradeoffs between strength and ductility can be made by machining conditions.



Microstructure of Fracture Surface



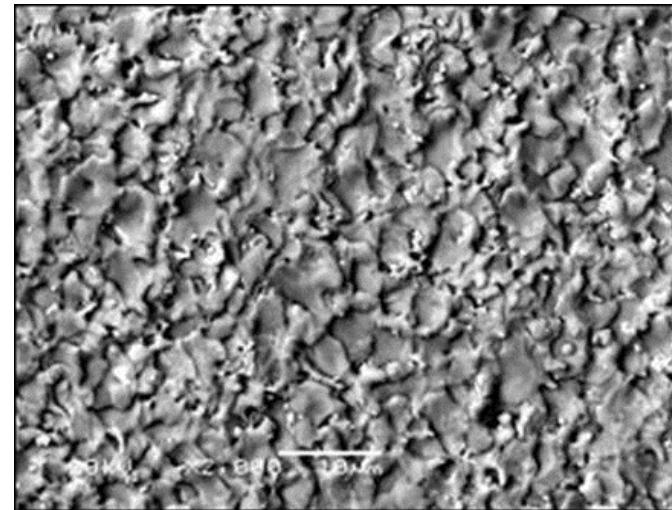
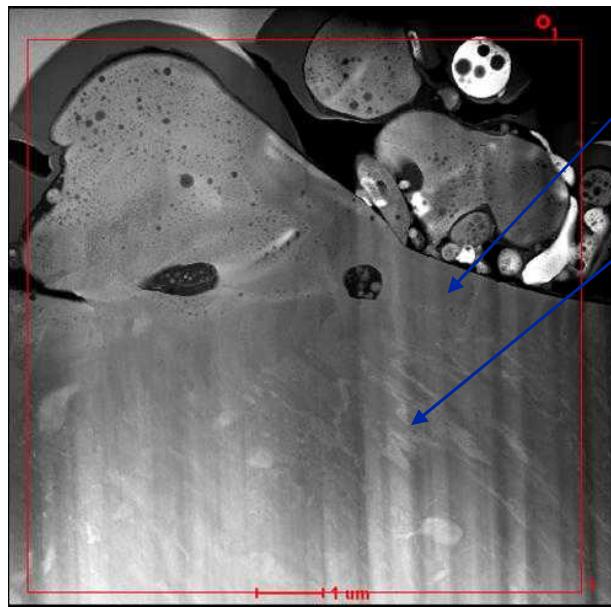
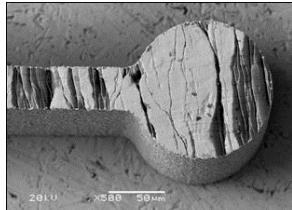
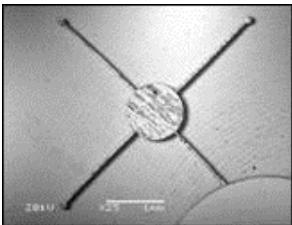
Dimpled rupture - ductile failure morphology

Brittle cracking and failure associated with Nb,Ti carbide particles (EMPA)

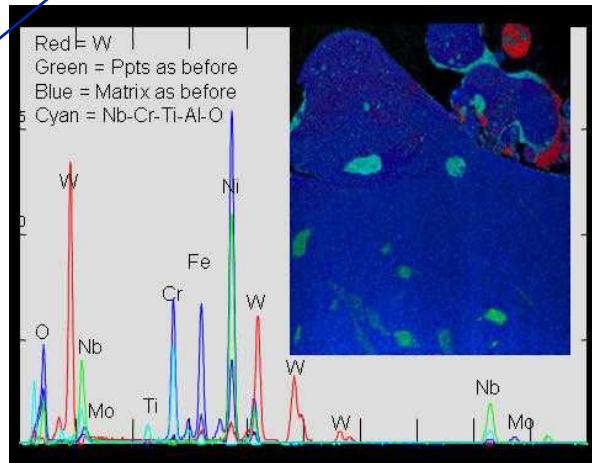
- Fracture surfaces of nanostructured Inconel 718 samples exhibited regions with both ductile and brittle failure morphologies.

Nanostructured bulk metals can be machined into components via μ -machining methods

μ wire
EDM

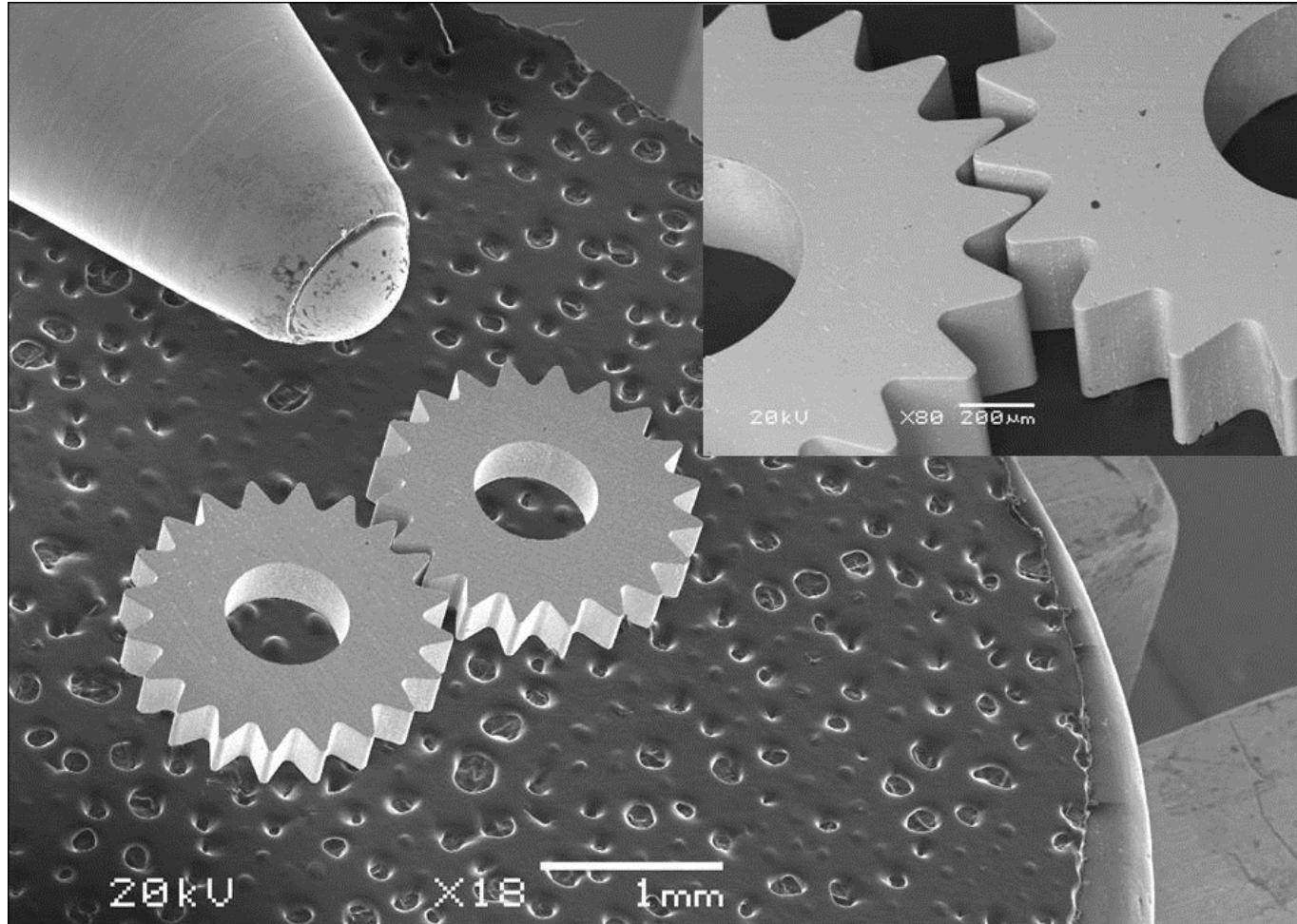


1 μ m recast layer (coarser microstructure)
Nanostructured Inconel





Prototype meso-scale component was made from nanostructured metals by μ wire EDM.





Summary

- Bulk nanostructured Inconel with high-strength was successfully fabricated by the extrusion-machining process.
- Increasing strain in LSEM process results in microstructure and mechanical property changes.
- μ -EDM is a viable process to fabricate meso-scale, nanostructured engineering components.



Acknowledgement

- Michael J. Rye and Paul G. Kotula – TEM sample preparation and investigation.
- Joseph R. Michael – SEM study
- Michael P. Saavedra – μ -wire EDM
- Alice C. Kilgo – Sample preparation
- David T. Schmale – Micro-tensile test
- Lysle M. Serna- Electropolishing
- Funding – LDRD program, Sandia National Laboratories



Fabrication of Nanostructured Inconel 718 Alloys by Large Strain Extrusion Machining

Pin Yang*, Thomas E. Buchheit, and David D. Gill

Sandia National Laboratories

Albuquerque, NM 87185-1245

Christopher J. Saldana and James Mann

Center for Advanced Manufacturing

Purdue University

West Lafayette, IN 47907-2023

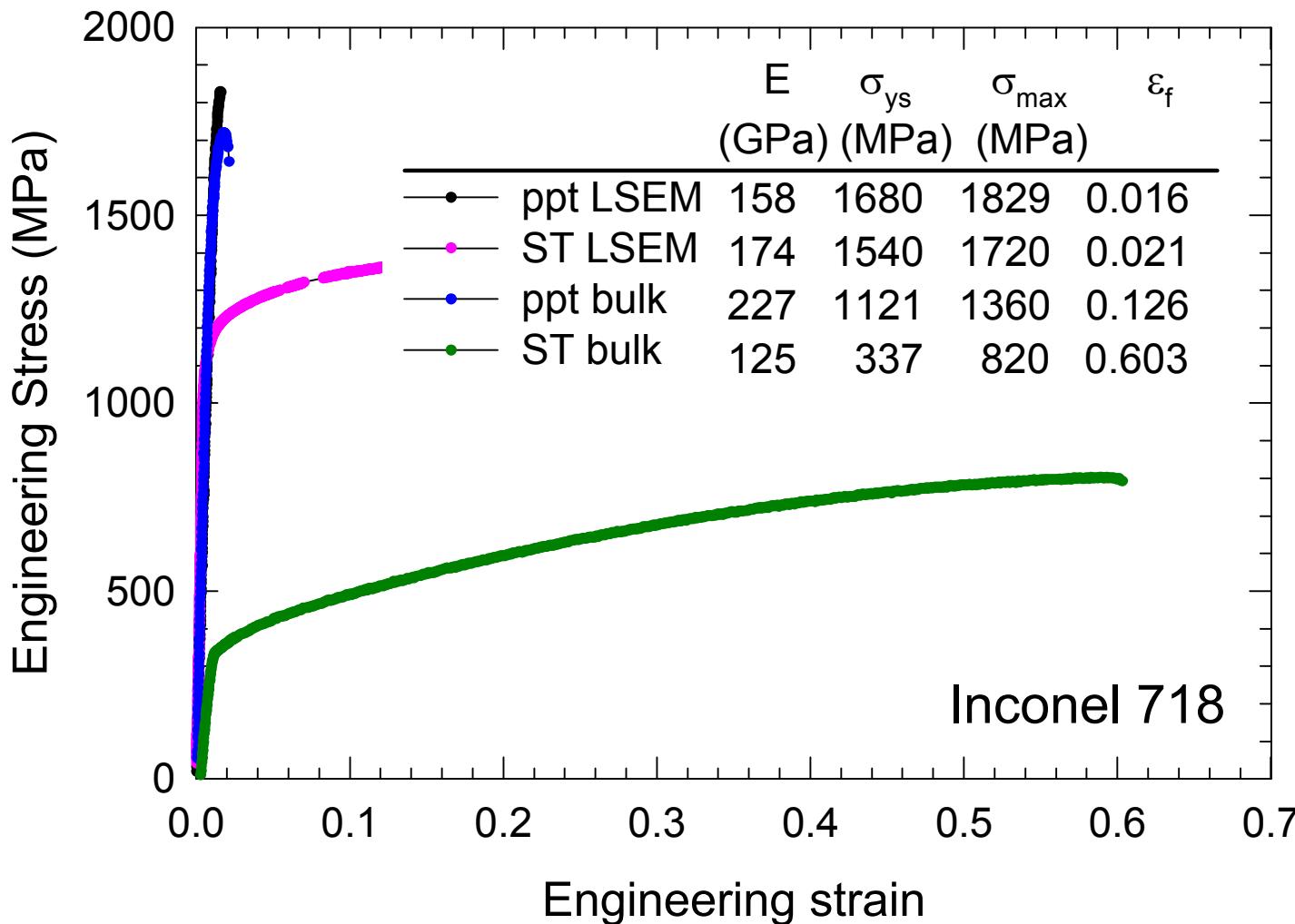
The 19th Annual Rio Grande Symposium on Advanced Materials
Albuquerque, New Mexico; October 9, 2007

Sandia is a multiprogram laboratory operated by Sandia Corporation, a Lockheed Martin Company,
for the United States Department of Energy's National Nuclear Security Administration
under contract DE-AC04-94AL85000.





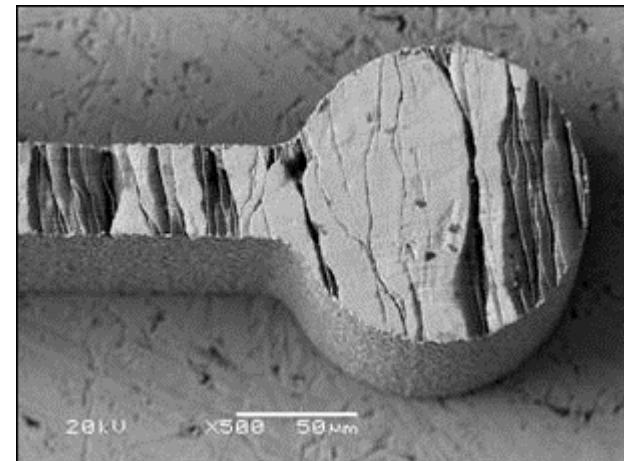
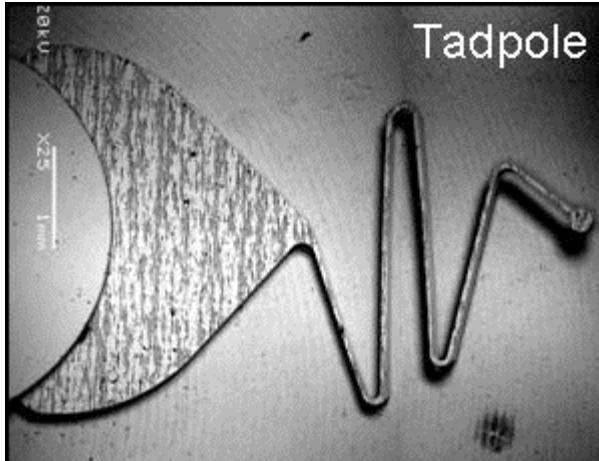
LSEM greatly increases the strength and reduces the ductility of Inconel 718 alloy.





Nanostructured Materials for Meso-Scale Components

- **Objectives:**
 - develop an effective manufacturing process to fabricate meso-scale components from nanostructured metals produced by Large Strain Extrusion Machining (LSEM).
 - Establish a processing-microstructure-property relationship for LSEM Inconel 718.



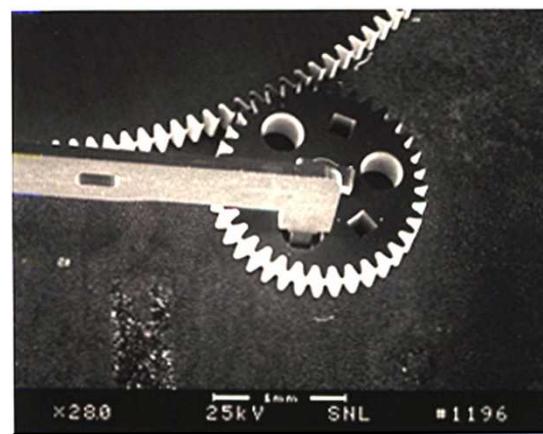


High-strength meso-scale components enable system miniaturization.

Miniature Machining



Meso Machining & LIGA



Silicon Surface Micromachining

 10^{-3} 10^{-4} 10^{-5} 10^{-6}

Critical dimensions (Meters)